

## 2016 Editorial Calendar

## July • August

Materials development of SiP & IoT	ICEPT 2016     Wuhan, China (Aug 16-19)     SEMICON Taiwan     Taipei, Taiwan (Sept 7-9)     BiTS China 2016     Suzhou, China (Sept 13)     ESTC     Grenoble, France (Sept 13-16)     MEPTEC     Medical Electronics Symposium     Portland, OR (Sept 14-16)     SEMI European MEMS Summit     Stuttgart, Germany (Sept 15-16)
Silicon 3D Integration for small power devices	
Solder reliability	
Environmental impact of packaging processes	
MEMS challenges in the IoT era	
Materials for test sockets	
Direct bonding technology	
Warpage in FCBGAs	

International Directory of Bonding Equipment for 2.5D and 3D Assembly

Ad Space Close Jun 24 - Ad Materials Close Jul 1

September • October	
Panel Level Packaging for FO-WLP	• IMAPS 2016 Pasadena, CA (Oct 11-13)
Probe card inspection	ICPT 2016     Beijing, China (Oct 17-19)     IWLPC-International Wafer-Level Packaging Conference & Exhibition San Jose, CA (Oct 18-20)     SEMICON Europa Grenoble, France (Oct 25-27)
Trends in TSV technologies	
Market update on multi-die ICs	
Bonding / debonding for heterogeneous integration	
Hermetic CSP for MEMS	
LED packaging	
Micro testing thin die	
SiP	

Ad Space Close Sep 9 - Ad Materials Close Sep 16

November • December	
FOWLP in the foundry	• MEMS Executive Congress
3D TSV assembly	Scottsdale, AZ (Nov 10-11)  • MEPTEC Semiconductor Packaging Roadmap Symposium San Jose, CA (Nov 14)  • International Test Conference (ITC) Fort Worth, TX (Nov 15-17)  • SEMICON Japan Tokyo, Japan (Dec 14-16)  • 3D ASIP Conference Redwood City, CA (Dec 15-17)
Die stacking	
High-frequency test sockets	
Wafer-level test	
High performance photoresist for advanced packaging	
Dicing of silicon carbide power devices	
Glass for semiconductor/optoelectronics packaging	
Interconnects for MEMS & sensors	

Ad Space Close Nov 4 - Materials Close Nov 11